

**REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL**

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,
provides for continued examination of an utility or plant application
filed on or after June 8, 1995.
See The American Inventors Protection Act of 1999 (AIPA).


Application Number	09/943324
Filing Date	August 30, 2001
First Named Inventor	Kie Y. Ahn
Group Art Unit	2818
Examiner Name	Phuc Dang
Attorney Docket Number	303.678US3
Customer No.	21186

This is a Request for Continued Examination (RCE) under 37 CFR § 1.114 of the above-identified application entitled STRUCTURE AND METHOD FOR DUAL GATE OXIDE THICKNESSES.

Submission required under 37 C.F.R. § 1.114

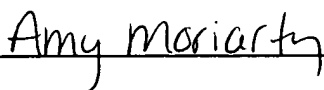
1. ☐ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on .
2. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on .
3. ☐ An Amendment Under 37 CFR § 1.116 (pages) is enclosed.
4. ☐ A new power of attorney (pages) is enclosed.
5. ☒ An Information Disclosure Statement is enclosed (1 page).
 - a. 1 Form(s) 1449
 - b. 1 Copies of IDS Citations
6. ☒ A check in the amount of \$770.00 is attached to pay the RCE filing fee required under C.F.R. § 1.17(e).
7. ☒ **The Commissioner is hereby authorized to credit overpayments or charge any fees set forth in 37 CFR §§ 1.16 through 1.18 to Deposit Account No. 19-0743.**
8. ☐ A Petition for Extension of Time in the prior application (pages) is enclosed along with a check in the amount of to pay the extension fee.
9. ☒ Others: Communication Concerning Related Applications (1 pg.).

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

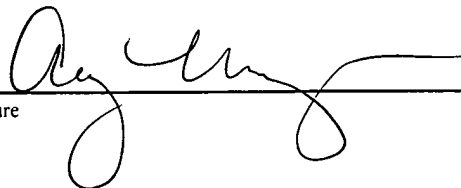
By: 
Atty: David C. Peterson
Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Attn-Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 7th day of January, 2004.

Name



Signature





S/N 09/943324

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al.

Examiner: Phuc Dang

Serial No.: 09/943324

Group Art Unit: 2818

Filed: August 30, 2001

Docket: 303.678US3

Title: STRUCTURE AND METHOD FOR DUAL GATE OXIDE THICKNESSES

COMMUNICATION CONCERNING RELATED APPLICATION(S)

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date</u>	<u>Attorney Docket</u>	<u>Title</u>
09/943398	August 30, 2001	303.678US2	STRUCTURE AND METHOD FOR DUAL GATE OXIDE THICKNESSES
09/943393	August 30, 2001	303.678US4	STRUCTURE AND METHOD FOR DUAL GATE OXIDE THICKNESSES

Respectfully submitted,

KIE Y. AHN ET AL.

By Applicants' Representatives,

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Date 1-07-04

By [Signature]

David C. Peterson
Reg. No. 47,857

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Name Amy Moriarty

Signature [Signature]